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SERIAL NUMBER 10/674,396	FILING DATE 10/01/2003 RULE	CLASS 118	GROUP ART UNIT 1763	ATTORNEY DOCKE NO. Q77312
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APPLICANTS

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** CONTINUING DATA *****

This application is a DIV of 08/866,331 05/30/1997 PAT 6,657,154

*TCU
2/24/05*

** FOREIGN APPLICATIONS *****

JAPAN 137895/1996 05/31/1996

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Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 10	TOTAL CLAIMS 4	INDEPENDENT CLAIMS 1
35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after allowance				

ADDRESS

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TITLE

Semiconductor manufacturing apparatus and manufacturing method of thin film semiconductor device

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue)
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